

Institute of Radiation Physics

Radiation Source ELBE

**Resolving Surface Chemical States of
p-GaN:Cs Photocathodes by
in-situ X-ray Photoelectron Spectroscopy (XPS)**

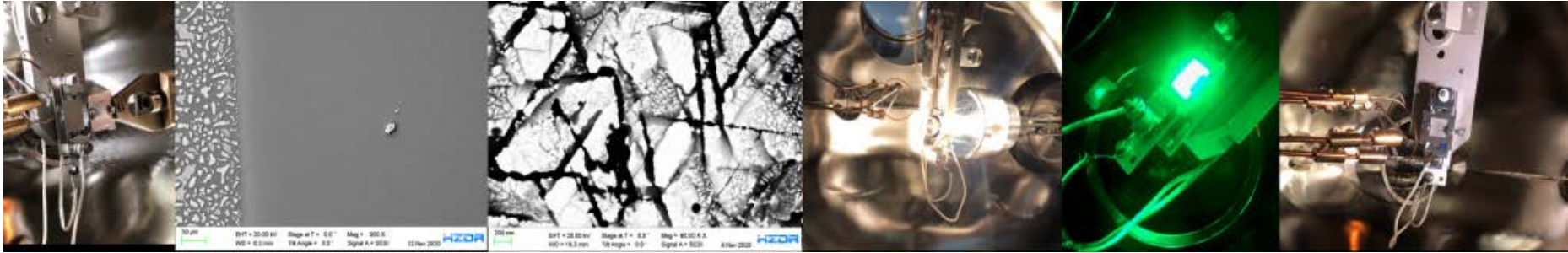
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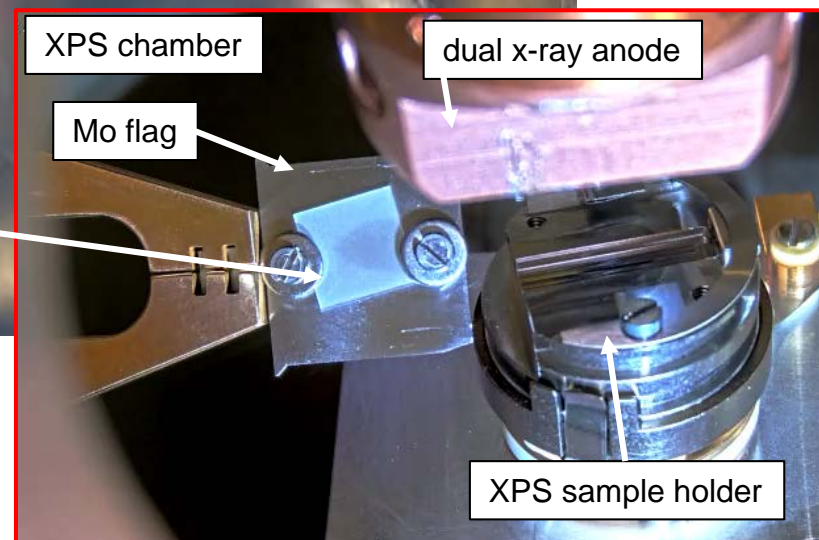
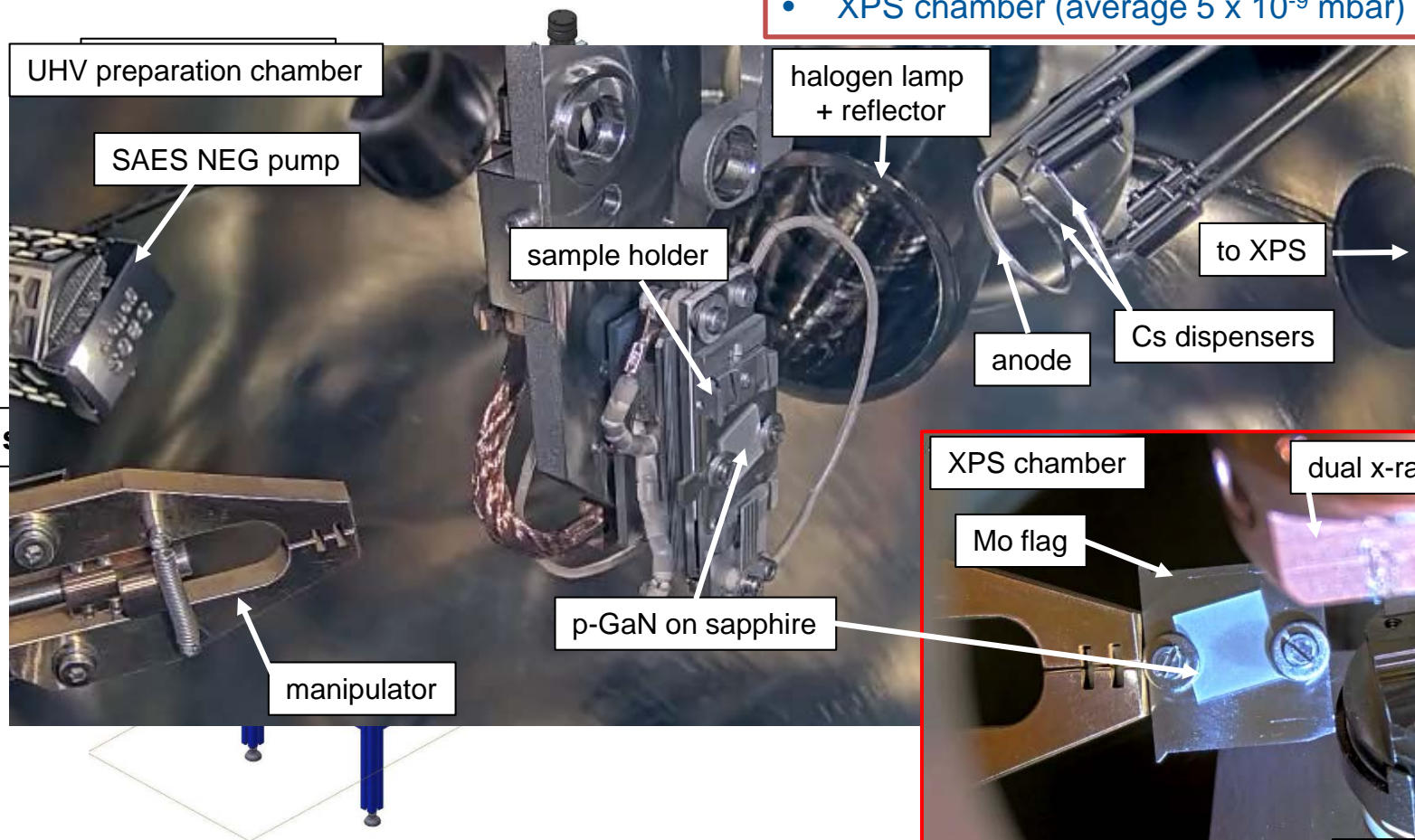
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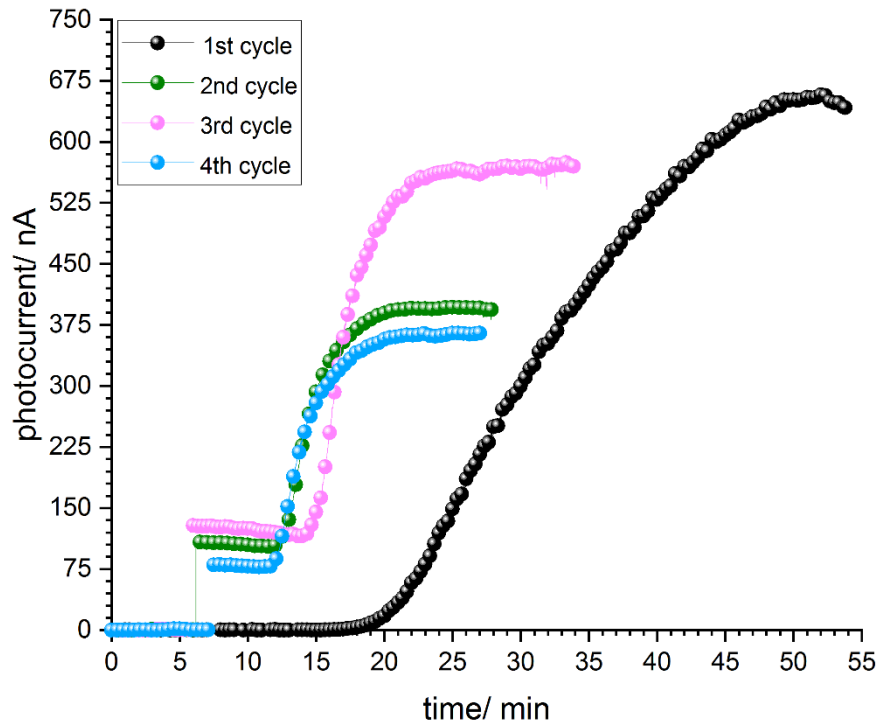
- Short overview of GaN chamber (Set-up)
- Activation cycle
- Achieved QE values vs. temperature
- Surface composition with XPS:
 - After thermal cleaning
 - After Ar⁺ sputtering
 - After Cs activation
 - Degradation (+ X-ray influence)
- Summary & Outlook

- UHV preparation chamber (average 3×10^{-10} mbar)
- 310 nm UV-LED with $50 \mu\text{W}$
- halogen lamp for thermal cleaning
- Backside heating by manipulator
- external IR sensor for temperature measurement
- XPS chamber (average 5×10^{-9} mbar)

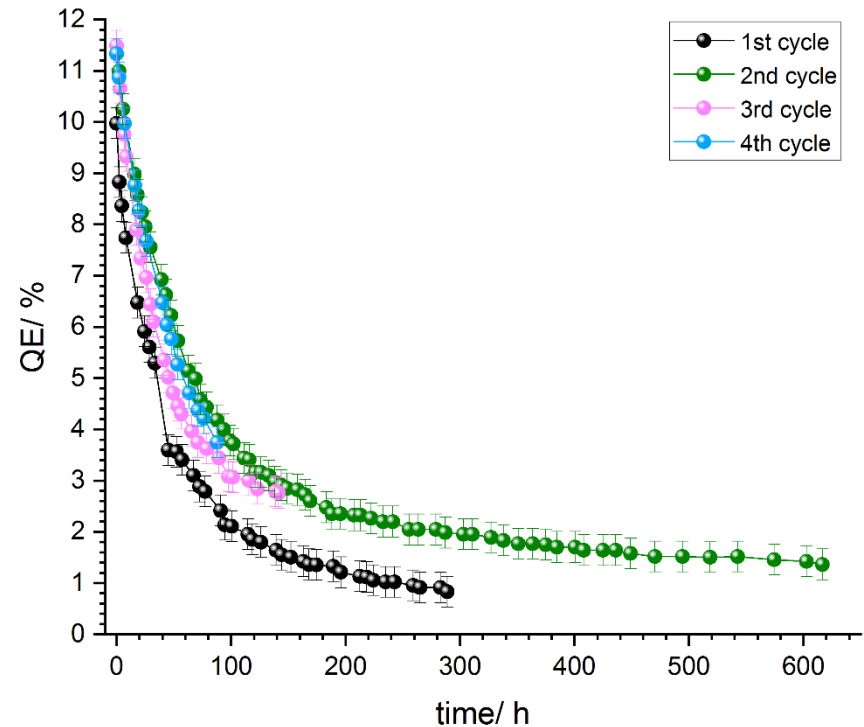


with courtesy of P. Murcek

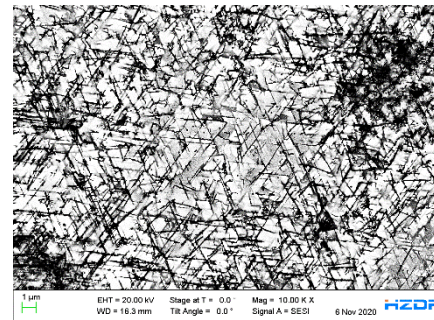
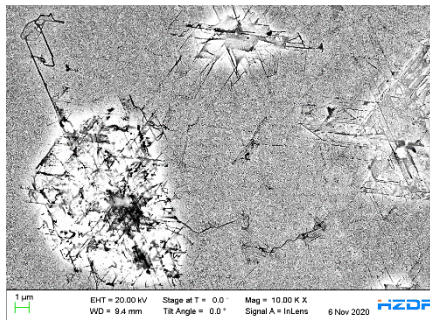
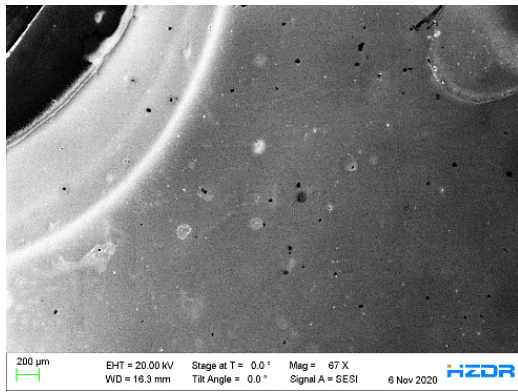
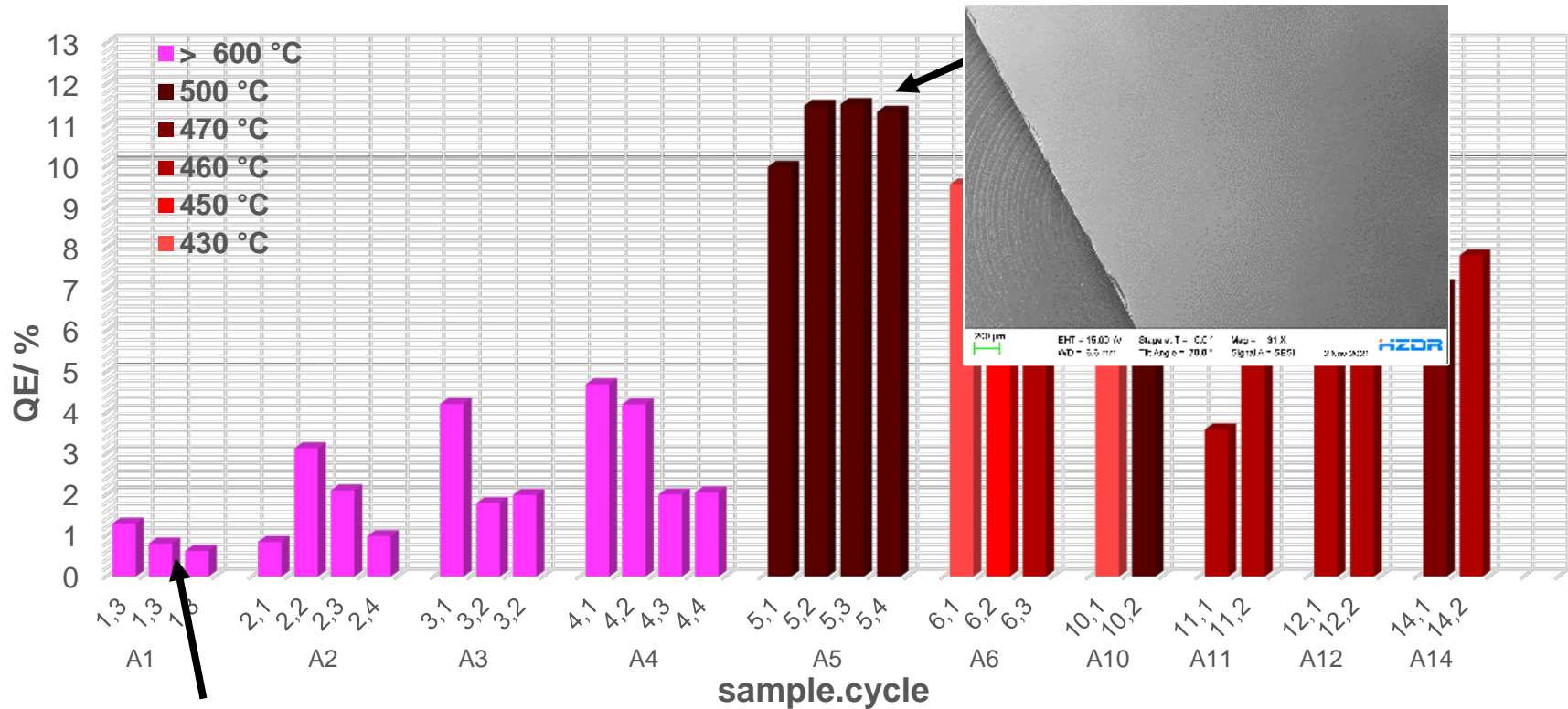
2. Cs activation



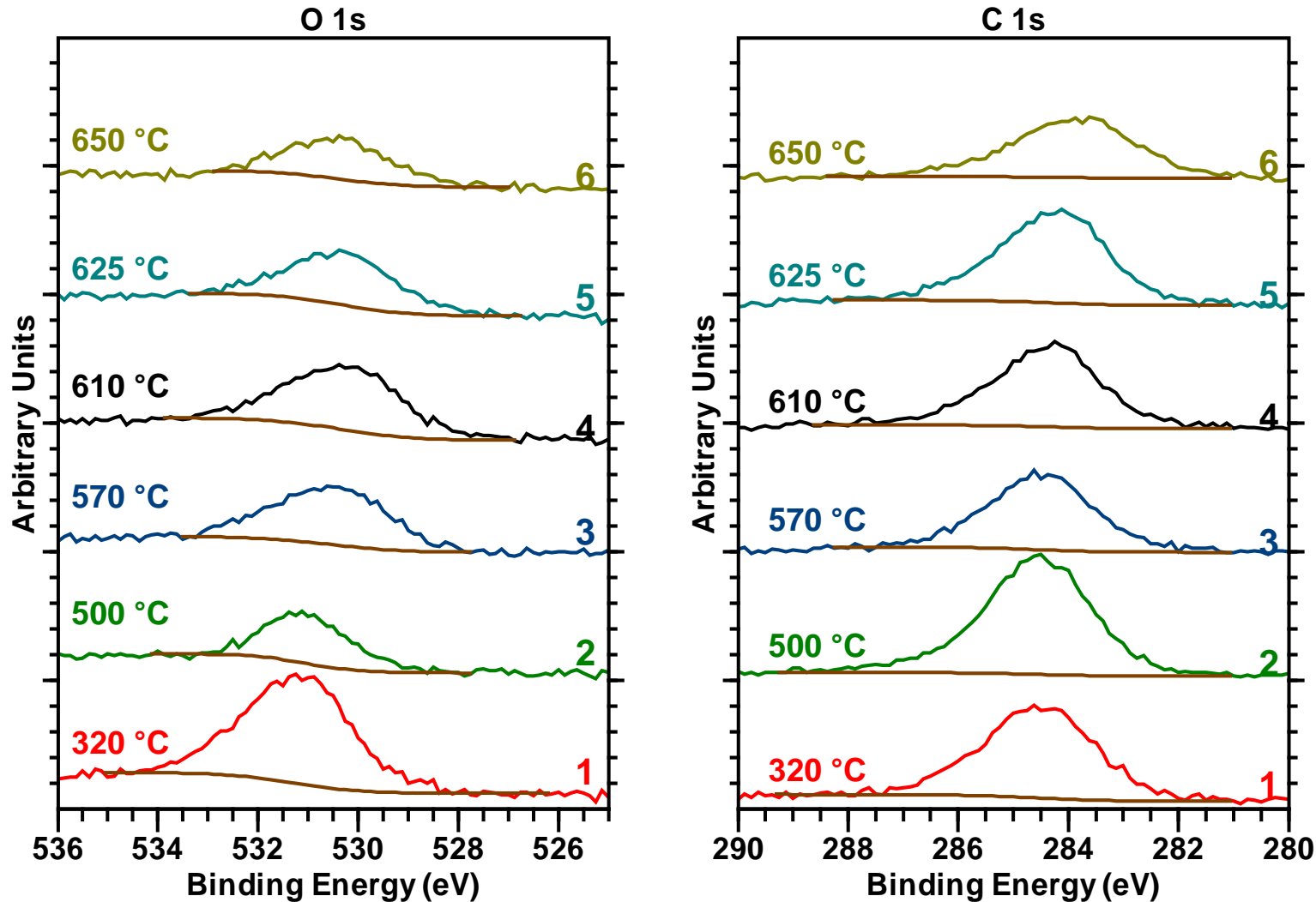
3. QE decay



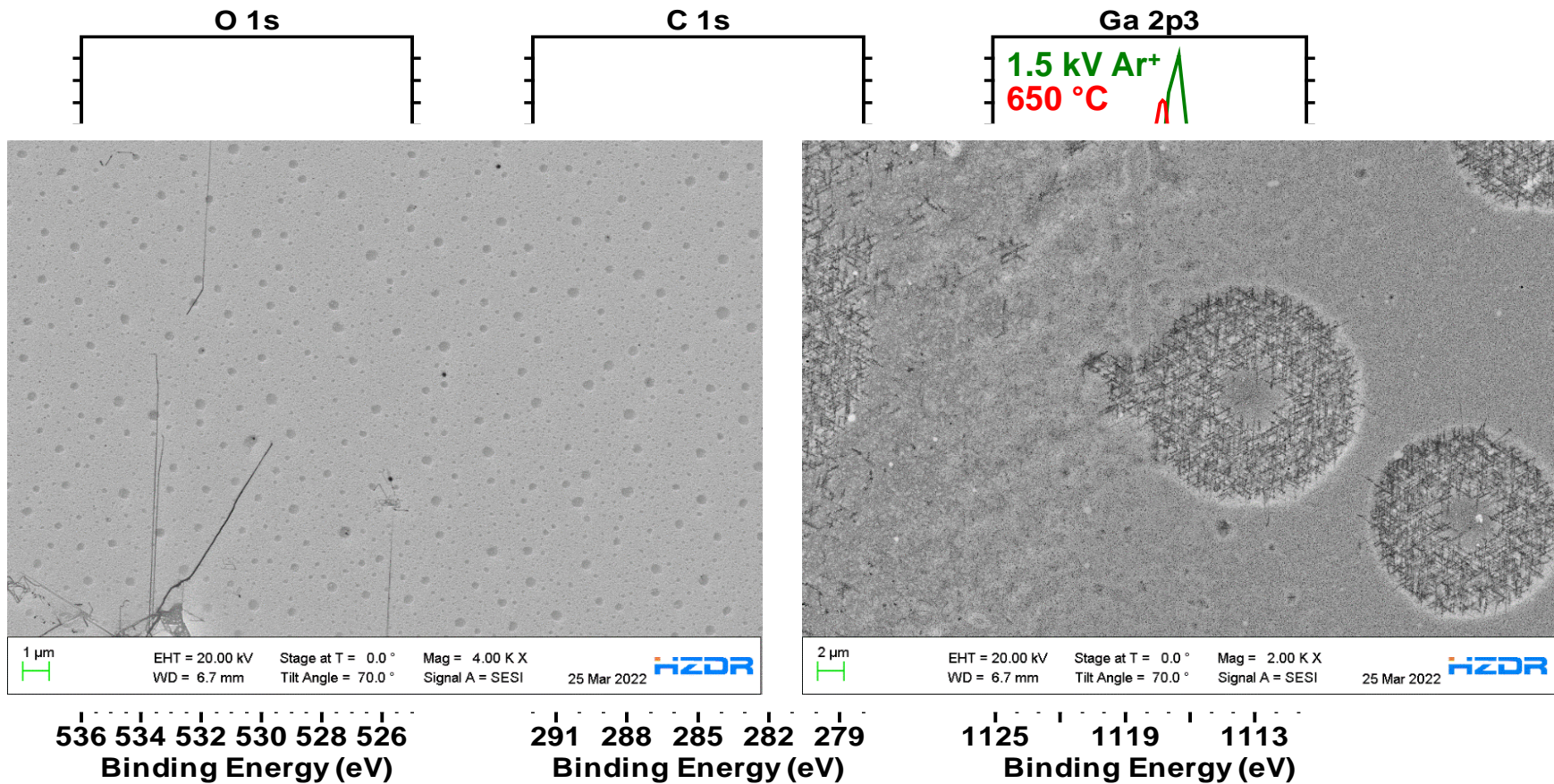
- Thermal cleaning, Cs activation and QE decay are defined as one cycle
- p-GaN can be used several cycles



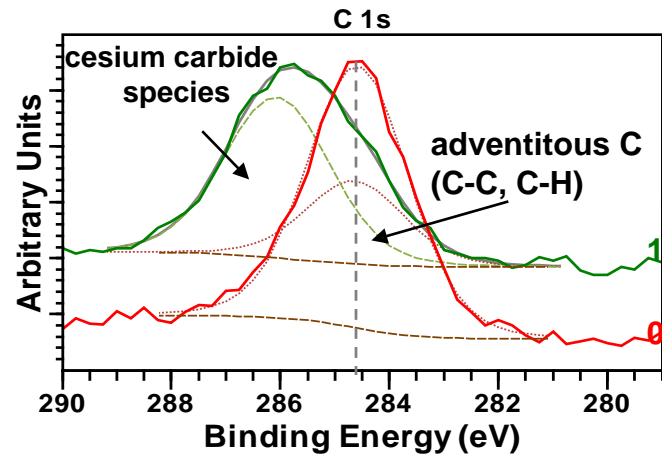
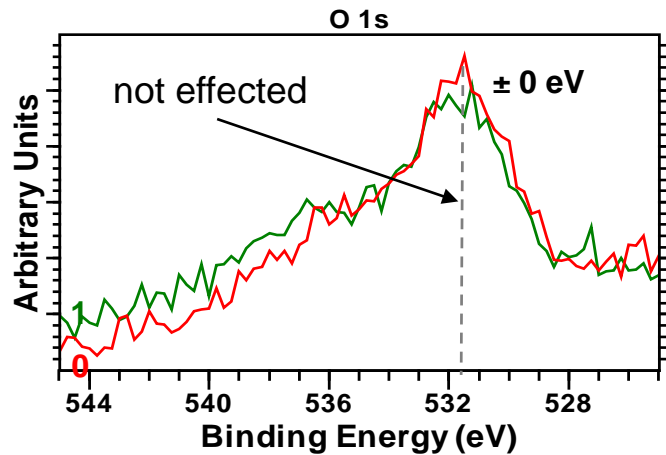
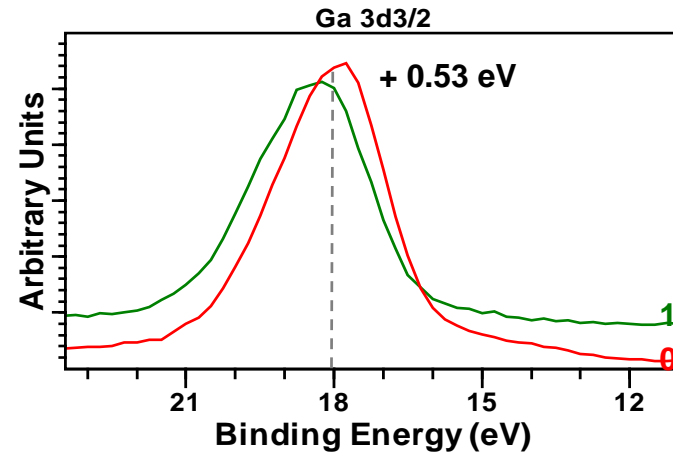
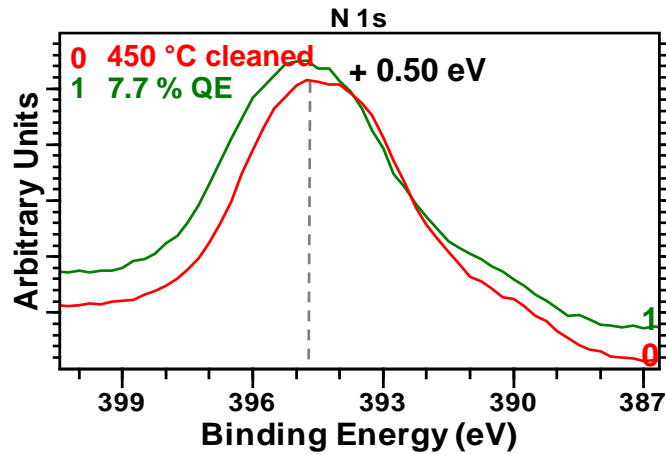
Surface composition after the thermal cleaning (backside)



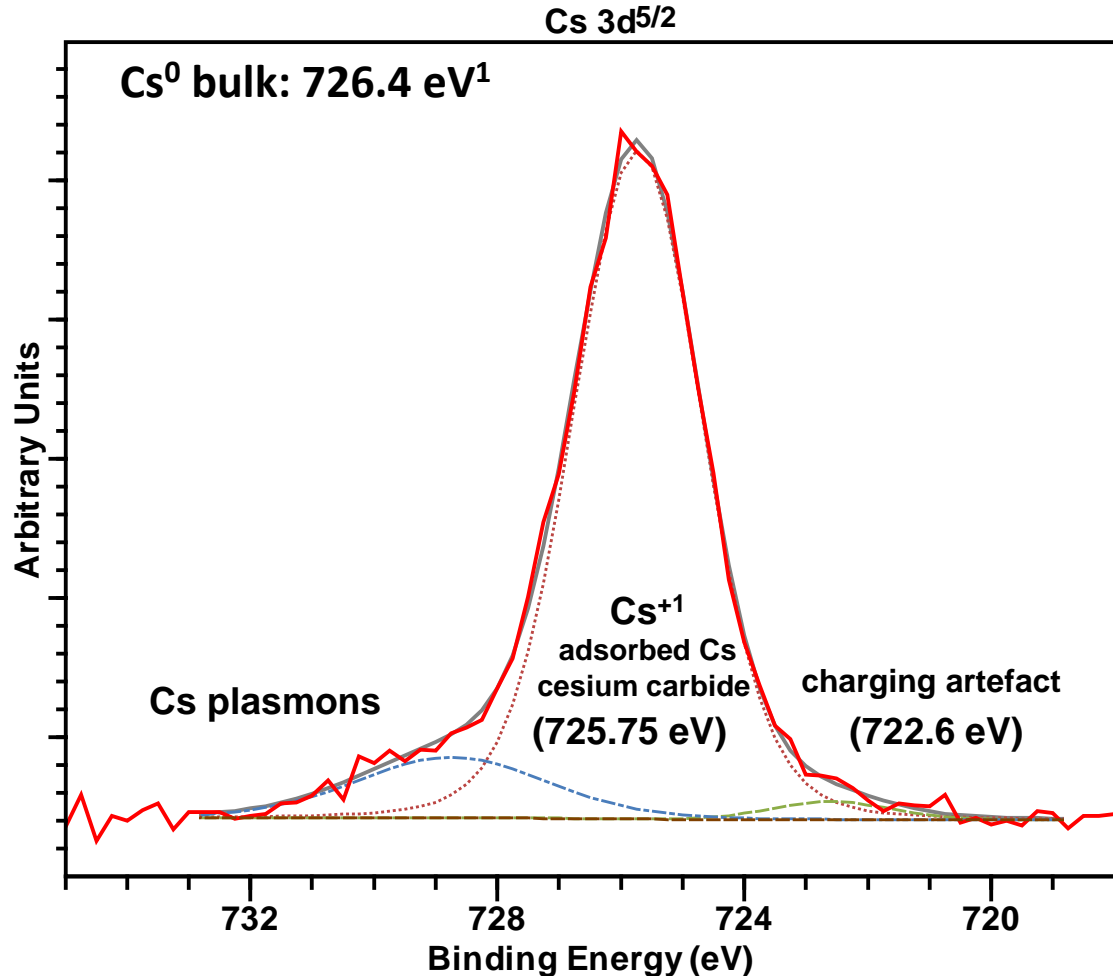
- C and O are not removed by thermal cleaning
- Might be incorporated into the crystal lattice



- Ar⁺ irradiation caused surface damage
- depletion in N atoms → Ga:N ratio is not 1 anymore !
- No NEA surface was achieved in Cs activation !



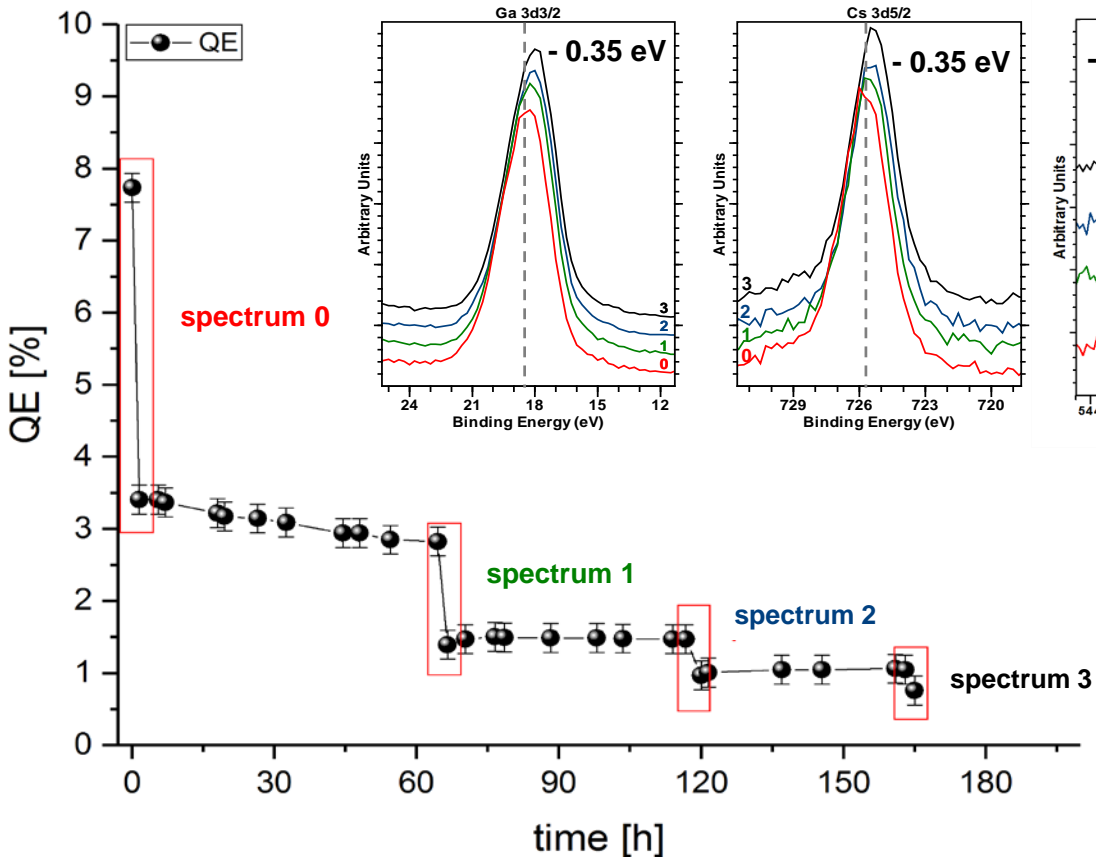
- Deposition of Cs: shift towards higher BE
- No shift in O 1s → oxygen is not at the surface → derive from sublayers/ incorporated
- Significant influence on C 1s peak: new component is formed



- Cs 3d_{5/2}: at lower BE than Cs⁰
- Cs must be Cs⁺¹
- No bulk Cs
- Cs plasmons with low intensity
- BUT: X-rays from dual anode has also an influence on degradation

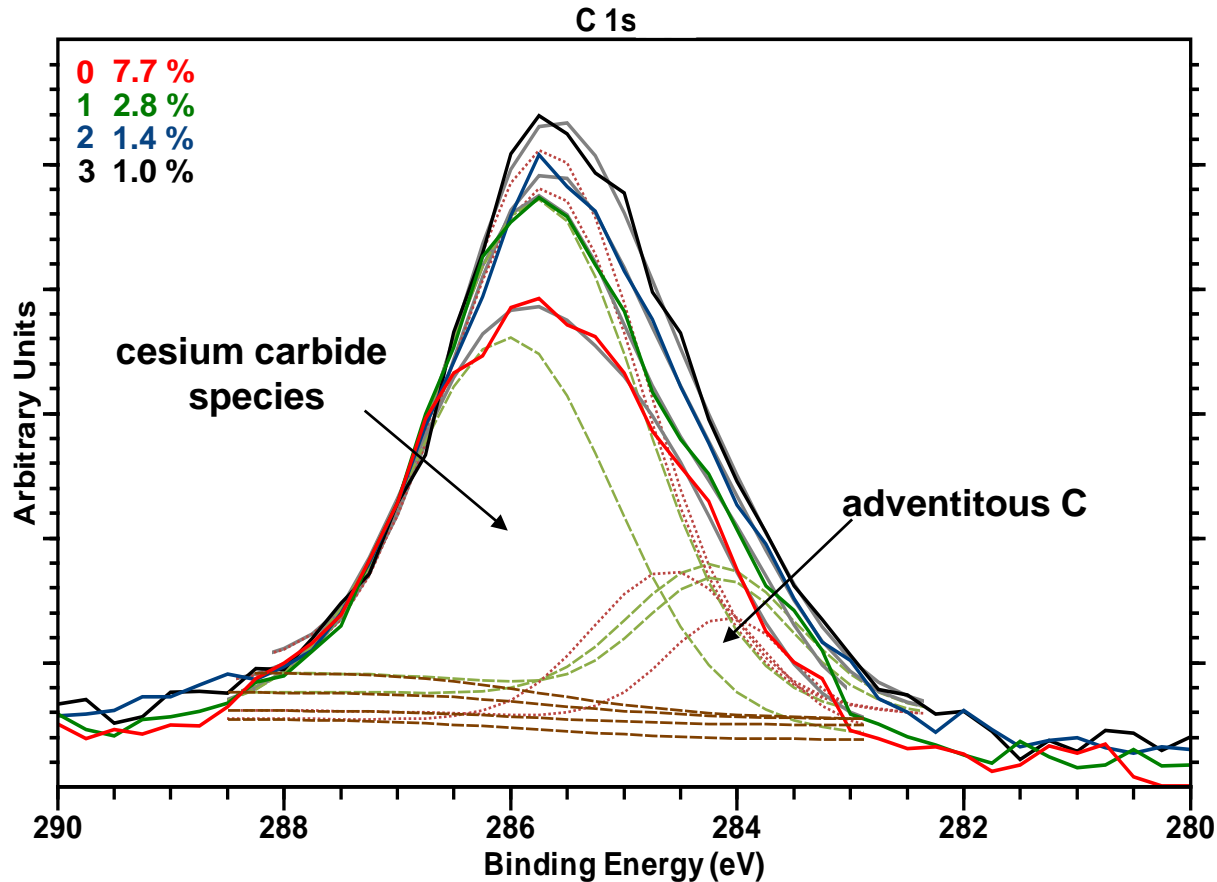
1) Moulder, J. F.; Jil C. Handbook of x-ray photoelectron spectroscopy: a reference book of standard spectra for identification and interpretation of XPS data. Physical Electronics Division, 1992, Perkin-Elmer Corp.

2) Schaber, J.; Xiang, R.; et al. Influence of Surface Carbon on p-GaN:Cs photocathodes with high quantum efficiency, publication in progress



- QE loss after XPS analysis
- QE decay should be exponentially
- XPS shows a shift towards lower BE during degradation
- BE shift also observed in O 1s

X-rays accelerate the degradation as external source



- Carbon is always at the surface
- Incorporated into the crystal
- Cesium carbide species increase in peak intensity

Increase in peak intensity is caused by:

- Carbon atoms that form a new species with Cs
- Carbon atoms that diffuse from sublayers to the surface
- Is there a cesium carbide island formation?

- QE values (7-12 %) @ 400-500 °C
- above 600 °C: surface morphology was destroyed
- *in-situ* XPS capability:
- C, O: incooperated during the MOCVD growth
 - removeable by Ar irradiation
 - BUT**: ion sputtering damage
- easy activation with excludsively cesium
- → photoemision peaks towards a higher BE
- Chemical state of Cs: no bulk Cs⁰ but Cs⁺¹
- C 1s peak was influenced
 - Cesium carbide species
 - Cesium carbide peak intensity increased with degradation
 - Shift back towards lower BE
- X-rays of dual anode accelerated the QE decay !

- Higher p-GaN quality (MBE or HVPE) → No C on the surface
- Different Mg concentrations
- P-GaN on other substrates (Si, Cu, SiC, TiN,)
- Sputtering with helium ???
- P-GaN behaviour in the SRF Gun ???

Thank you for your attention !